



In re Applicant:

Daniel Xu et al.

Art Unit:

2815

Serial No.:

09/976,641

Examiner:

B. Baumeister

Filed:

October 12, 2001

Atty Docket: ITO.0504US

P12497

For:

Reducing Leakage Currents in

Memories With Phase-Change

Material

Mail Stop AF Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

TC 2800 HAIL ROOM

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed December 18, 2003, please amend the abovereferenced patent application as follows:

> Date of Deposit:_ December 30, 2003

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is P.O. Box 1450, addressed to the Commissioner for Patents, Alexandria, VA 22313-1450

Cynthia L Hayden